















**Course Schedule, group M23-213****MONDAY**

10:15 — 13:30	■ PR	Practical Training (Research Work)  Trikshev A.I.  ДОТ
10:15 — 14:20	■ SEM	Principles of Design and Manufacture of Lasers and Their Components (2024-09-30 — 2024-12-09)  Evtihiev N.N.  NTO IRE Polyus



**TUESDAY**

08:30 — 10:05	■ LEC	Opt Military Training (2024-09-03 — 2024-12-17)  dep.20
10:15 — 17:00	■ SEM	Opt Military Training (2024-09-03 — 2024-12-17)  dep.20

**WEDNESDAY**

10:15 — 11:50	■ LEC	Laser micro and nanotechnologies (2024-09-04 — 2024-09-25)  Konov V.I.  IOF RAN
	■ SEM	Laser micro and nanotechnologies (2024-10-02 — 2024-12-11)  Konov V.I.  IOF RAN
12:45 — 13:30	■ LEC	Digital Modeling, Calculation and Design of Nanosystems  Osadchiy A.V.  IOF RAN
13:35 — 15:15	■ SEM	Digital Modeling, Calculation and Design of Nanosystems  Osadchiy A.V.  IOF RAN

**FRIDAY**

16:15 — 17:50	■ LEC	Management and Marketing (2024-09-06 — 2024-11-22)  Prohorov I.V., Stepanova E.B.  403
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